



THE UNITED STATES PATENT & TRADEMARK OFFICE

Application Number : 10/725,320 Confirmation No. 5389
Applicant : Kwan-Yong LIM, et al.
Filed : 12/02/03
Tech Cntr/AU : 2825
Examiner : Anya, Igwe U
Entitled : METHOD FOR FABRICATING GATE-ELECTRODE OF
SEMICONDUCTOR DEVICE WITH USE OF HARD MASK

Attorney Reference : 123037-05005020
Customer Number : 43569

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

EXTENSION OF TIME

A petition for extension of time under 37 C.F.R. 1.136 for two month (PTO/SB/22) is attached hereto in duplicate.

CLAIM FEES

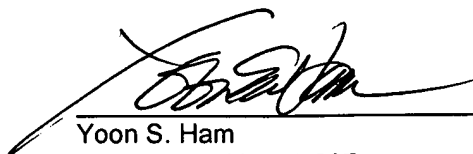
The claim fees have been calculated as follows:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total	14	-	20	= 0 x \$ 50.00	= \$ 0.00
Independent	2	-	3	= 0 x \$ 0.00	= \$ 0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM+ \$ 360.00					= \$ 0.00
TOTAL ADDITIONAL CLAIM FEE DUE					\$ 0.00

FEE PAYMENT

Authorization is given herein to charge the any deficiencies in the fees not specifically authorized herein, or to further credit any overpayments, to Deposit Account No. 503-121 in order to maintain the pendency of this application.

Intellectual Property Department
Mayer Brown Rowe & Maw LLP
1909 K Street, N.W.
Washington, D.C. 20006-1101



Yoon S. Ham
Registration No. 45,307
(202) 263-3280

Date: February 8, 2005